

Electronic Patent Application Fee Transmittal

Application Number:	10673173			
Filing Date:	30-Sep-2003			
Title of Invention:	Substrate processing apparatus and substrate processing method			
First Named Inventor/Applicant Name:	Yukihiko Nakata			
Filer:	Marvin Jay Spivak/Cecelia Davis			
Attorney Docket Number:	243339US3			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 4 months with \$0 paid	1254	1	1640	1640

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	810	810
Total in USD (\$)				2450